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JAN 27 2006
PATENT & TRADEMARK OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of	:	**Confirmation No. 6454**
Shigeru YOKOI et al.	:	Attorney Docket No. 2003_1452A
Serial No. 10/681,141	:	Group Art Unit 1751
Filed October 9, 2003	:	Examiner Gregory E. Webb

CLEANING LIQUID USED IN PHOTOLITHOGRAPHY AND A METHOD FOR TREATING SUBSTRATE THEREWITH

Mail Stop: Amendment

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of July 27, 2005.

The fee of $1,020.00 is
(X) submitted herewith.
() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

() Small entity status of this application is established by a Small Entity Status Assertion which
  () is enclosed.
  () has been previously submitted.

Respectfully submitted,

Shigeru YOKOI et al.

By _____
Matthew M. Jacob
Registration No.25,154
Attorney for Applicants

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January 27, 2006